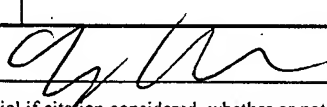


INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number		
				92478-2600		10/533,605		
				Applicant(s)				
				Yukihiro Morita				
				Filing Date		Group Art Unit		
				04/29/2005		2879		
U. S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
R		6,379,783	4/30/2002	Kim et al.				
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EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
R		08-236028	13.09.1996	Japan w/ English abstract			X	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
R		Son Choongyong et al., "Stoichiometry dependency of the firing and sustain voltage properties of MgO thin films for alternating current plasma display panels", Journal of Vacuum Science and Technology A. Vacuum, Surfaces and Films, American Institute of Physics, New York, NY, US, vol. 17, no. 5, September 1999, pages 2619-2622.						
EXAMINER					DATE CONSIDERED			
					10/15/07			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								